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PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10029147	FILING DATE 12/28/2001	CLASS 438	SUBCLASS 692	GAU 282 2012	EXAMINER S. J. J. J. J.
<b>**APPLICANTS:</b> Lee Young-Goo; Kim Tae-Ryong; Kim Jin-Sung; Kim Jin-Joo; An Jung-Soo; Song Jong-Kook;					
<b>**CONTINUING DATA VERIFIED:</b>					
<b>**FOREIGN APPLICATIONS VERIFIED:</b> REPUBLIC OF KOREA 2001-2218 01/15/2001					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO			
35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no		SEC. 875			
Verified and Acknowledged Examiners's initials <b>MG</b>					
<b>TITLE :</b> Method of fabricating semiconductor device for preventing contaminating particle generation					

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<b>NOTICE OF ALLOWANCE MAILED</b>		<b>CLAIMS ALLOWED</b>	
		Total Claims	Print Claim for O.G.
<b>ISSUE FEE</b>		<b>DRAWING</b>	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg.
		Print Fig.	
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		Application Examiner	
		<b>PREPARED F R ISSUE</b>	
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